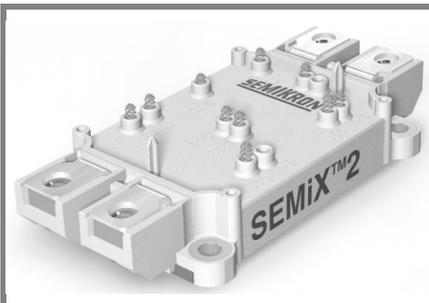


# SEMiX 402GB066HDs



SEMiX® 2s

## Trench IGBT Modules

### SEMiX 402GB066HDs

#### Target Data

#### Features

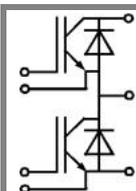
- Homogeneous Si
- Trench = Trenchgate technology
- $V_{CE(sat)}$  with positive temperature coefficient

#### Typical Applications

- Matrix Converter
- Resonant Inverter
- Current Source Inverter

#### Remarks

- Case temperature limited to  $T_C = 125^\circ\text{C}$  max.
- Product reliability results are valid for  $T_j = 150^\circ\text{C}$
- SC data:  $t_p \leq 6 \mu\text{s}$ ;  $V_{GE} \leq 15 \text{ V}$ ;  $T_j = 150^\circ\text{C}$ ;  $V_{CC} = 360 \text{ V}$



GB

Absolute Maximum Ratings		$T_{case} = 25^\circ\text{C}$ , unless otherwise specified	
Symbol	Conditions	Values	Units
<b>IGBT</b>			
$V_{CES}$		600	V
$I_C$	$T_c = 25 (80)^\circ\text{C}$ , $T_j = 150^\circ\text{C}$	490 (340)	A
$I_C$	$T_c = 25 (80)^\circ\text{C}$ , $T_j = 175^\circ\text{C}$	530 (410)	A
$I_{CRM}$	$t_p = 1 \text{ ms}$	800	A
$V_{GES}$		$\pm 20$	V
$T_j, (T_{stg})$		-40 ... +175 (125)	$^\circ\text{C}$
$V_{isol}$	AC, 1 min.	4000	V
<b>Inverse diode</b>			
$I_F$	$T_c = 25 (80)^\circ\text{C}$ , $T_j = 150^\circ\text{C}$	380 (250)	A
$I_F$	$T_c = 25 (80)^\circ\text{C}$ , $T_j = 175^\circ\text{C}$	420 (310)	A
$I_{FRM}$	$t_p = 1 \text{ ms}$	800	A
$I_{FSM}$	$t_p = 10 \text{ ms}$ ; sin.; $T_j = 25^\circ\text{C}$	1800	A

Characteristics		$T_{case} = 25^\circ\text{C}$ , unless otherwise specified			
Symbol	Conditions	min.	typ.	max.	Units
<b>IGBT</b>					
$V_{GE(th)}$	$V_{GE} = V_{CE}$ , $I_C = 3,2 \text{ mA}$		5,8		V
$I_{CES}$	$V_{GE} = 0$ , $V_{CE} = V_{CES}$ , $T_j = 25 ( )^\circ\text{C}$			0,1	mA
$V_{CE(TO)}$	$T_j = 25 (150)^\circ\text{C}$	0,9 (0,85)		1 (0,9)	V
$r_{CE}$	$V_{GE} = 15 \text{ V}$ , $T_j = 25 (150)^\circ\text{C}$	1,4 (2,15)		2,25 (3)	m $\Omega$
$V_{CE(sat)}$	$I_{Cnom} = 400 \text{ A}$ , $V_{GE} = 15 \text{ V}$ , $T_j = 25 (150)^\circ\text{C}$ , chip level	1,45 (1,7)		1,9 (2,1)	V
$C_{ies}$	under following conditions				nF
$C_{oes}$	$V_{GE} = 0$ , $V_{CE} = 25 \text{ V}$ , $f = 1 \text{ MHz}$				nF
$C_{res}$					nF
$L_{CE}$					nH
$R_{CC+EE}$	terminal-chip, $T_c = 25 (125)^\circ\text{C}$				m $\Omega$
$t_{d(on)}/t_r$	$V_{CC} = 300 \text{ V}$ , $I_{Cnom} = 400 \text{ A}$				ns
$t_{d(off)}/t_f$	$V_{GE} = \pm 15 \text{ V}$				ns
$E_{on} (E_{off})$	$R_{Gon} = R_{Goff} = 8 \Omega$ , $T_j = 150^\circ\text{C}$		11 (17)		mJ
<b>Inverse Diode</b>					
$V_F = V_{EC}$	$I_{Fnom} = 400 \text{ A}$ ; $V_{GE} = 0 \text{ V}$ ; $T_j = 25 (150)^\circ\text{C}$ , chip level	1,4 (1,4)		1,6	V
$V_{(TO)}$	$T_j = 25 (150)^\circ\text{C}$	1 (0,85)		1,1	V
$r_T$	$T_j = 25 (150)^\circ\text{C}$	1 (1,4)		1,25	m $\Omega$
$I_{RRM}$	$I_{Fnom} = 400 \text{ A}$ ; $T_j = 25 (150)^\circ\text{C}$				A
$Q_{rr}$	$di/dt = \text{A}/\mu\text{s}$				$\mu\text{C}$
$E_{rr}$	$V_{GE} = -15 \text{ V}$				mJ
<b>Thermal characteristics</b>					
$R_{th(j-c)}$	per IGBT			0,11	K/W
$R_{th(j-c)D}$	per Inverse Diode			0,2	K/W
$R_{th(j-c)FD}$	per FWD				K/W
$R_{th(c-s)}$	per module		0,045		K/W
<b>Temperature sensor</b>					
$R_{25}$	$T_c = 25^\circ\text{C}$		5 $\pm$ 5%		k $\Omega$
$B_{25/85}$	$R_2 = R_1 \exp[B(1/T_2 - 1/T_1)]$ ; $T[K]$ ; $B$		3420		K
<b>Mechanical data</b>					
$M_s/M_t$	to heatsink (M5) / for terminals (M6)	3/2,5		5 / 5	Nm
w			250		g

